

Laser-TCT with Allpix²

Overview of the `allpix::DepositionLaserModule` and some comparisons with experimental data.

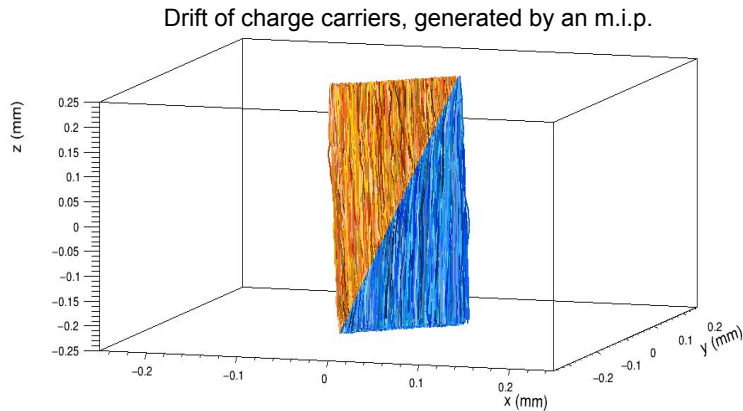
Daniil Rastorguev

5th Allpix Squared User Workshop

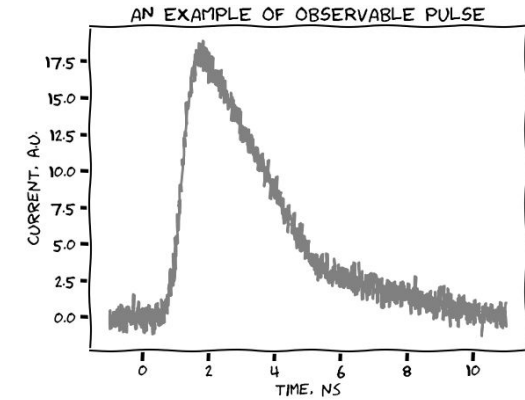
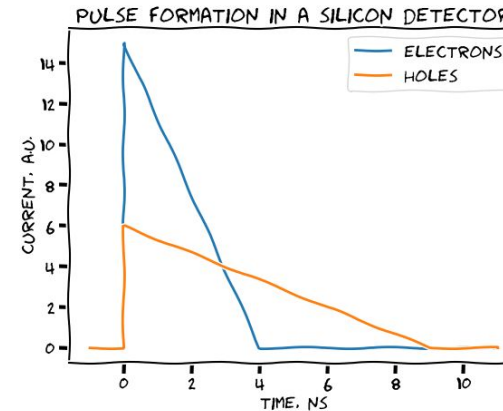
24.05.2024

Transient Current Technique (TCT) basics

Signal formation principles and sensor features



$$I(t) = q\vec{v}(t) \cdot \vec{E}_W(\vec{r}(t))$$



Bulk spatial features that are *encoded* in the pulse shape:

- Electric field
- Weighting potential
- Depletion region

Application domains:

- Radiation-damaged sensors
- Sensors with complex structure

The experiment:

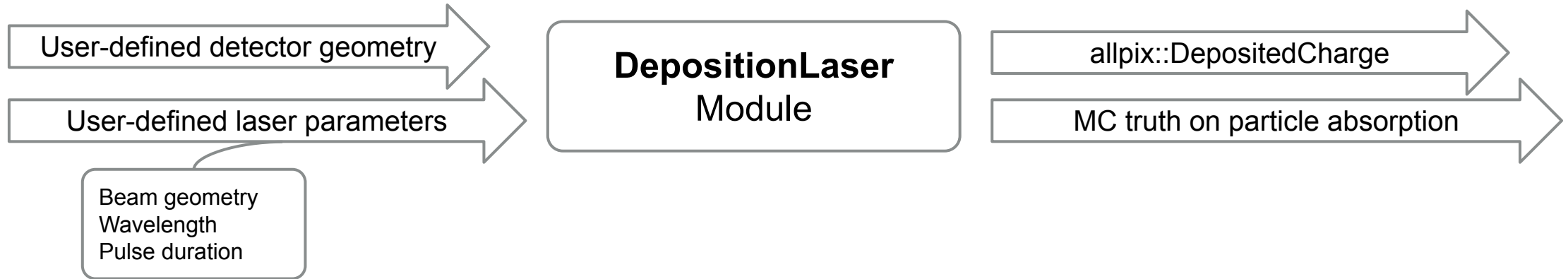
- inject charge in a controlled way
- study transient pulses

E.g., with a pulsed laser

How to simulate laser charge injection with Allpix²?

allpix::DepositionLaserModule

A dedicated event generator for energy deposition with pulsed lasers



→ The module is available in `Allpix2` since v2.4.0!

<https://gitlab.cern.ch/allpix-squared/allpix-squared/-/tree/master/src/modules/DepositionLaser>

Features:

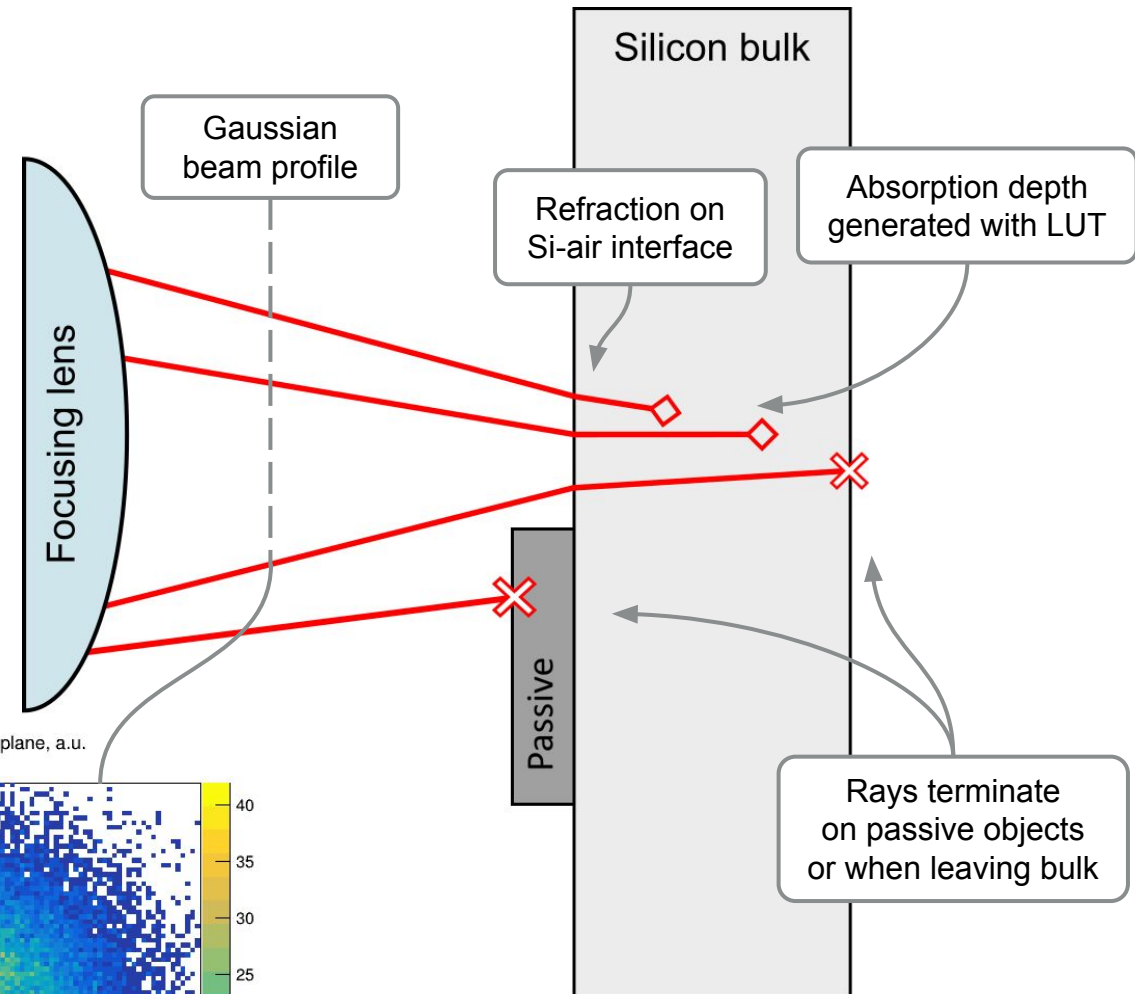
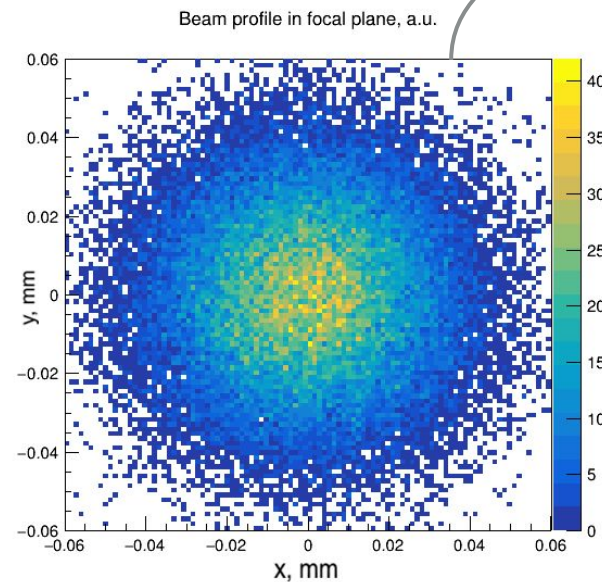
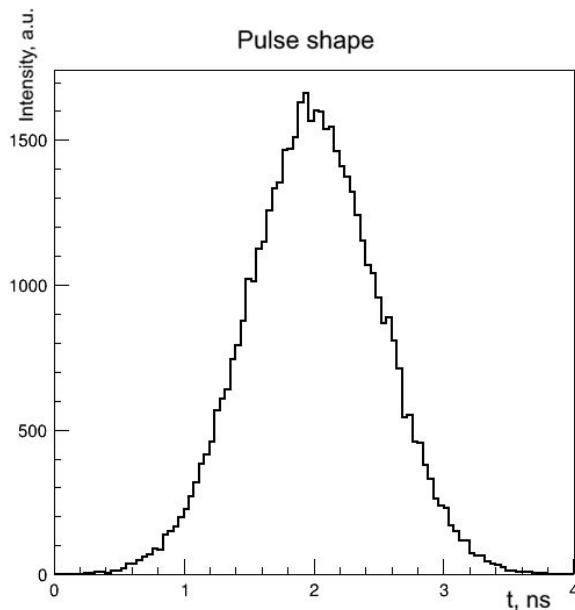
- No dependency on Geant4
- Follows modular approach of `Allpix2`
- Full compatibility with `Allpix2` geometry (passive objects, multi-detector setups)
- Follows sustainable development philosophy of `Allpix2`

allpix::DepositionLaserModule

Simulation principle

Simulation features:

- Laser pulse is modelled as a set of **individual photons**, each considered a *straight ray*
- Intensity distribution reproduces a **gaussian beam**
- Adjustable **pulse duration**
- Experiment-based **lookup table** [1] with absorption and refraction coefficients for different wavelengths



[1] <https://doi.org/10.1002/pip.4670030303>

Module usage and features

```
[Allpix]  
number_of_events = 1
```

A few events (or one)
is usually enough

Each event is compute-heavy!
Consider using `group_photons`

Module usage and features

```
[Allpix]
```

```
number_of_events = 1
```

```
[DepositionLaser]
```

```
# Specify beam geometry
```

```
source_position = 0mm 0mm -5mm
```

```
beam_direction = 0 0 1
```

```
beam_geometry = "converging"
```

```
beam_waist = 10um
```

```
focal_distance = 5mm
```

```
beam_convergence_angle = 20deg
```

A few events (or one)
is usually enough

Each event is compute-heavy!
Consider using `group_photons`

No need to call
`[GeometryBuilderGeant4]`

Module usage and features

[Allpix]

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number_of_events = 1
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[DepositionLaser]

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# Specify beam geometry
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source_position = 0mm 0mm -5mm
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```
beam_geometry = "converging"
```

```
beam_waist = 10um
```

```
focal_distance = 5mm
```

```
beam_convergence_angle = 20deg
```

```
# Specify parameters of the pulse
```

```
wavelength = 1064nm
```

```
number_of_photons = 10000
```

```
pulse_duration = 1ns
```

A few events (or one)
is usually enough

Each event is compute-heavy!
Consider using `group_photons`

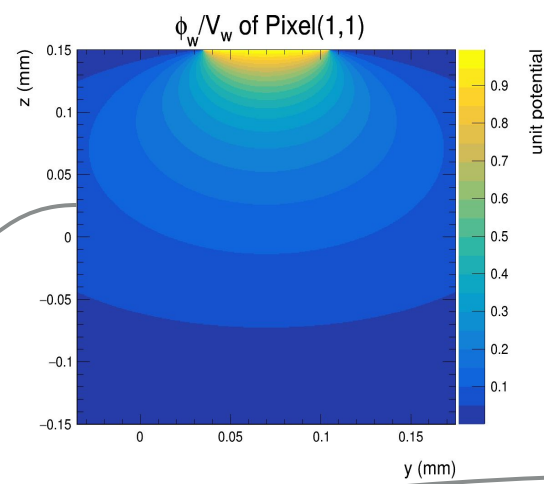
No need to call
[GeometryBuilderGeant4]

Or explicitly define
`absorption_length` and `refractive_index`

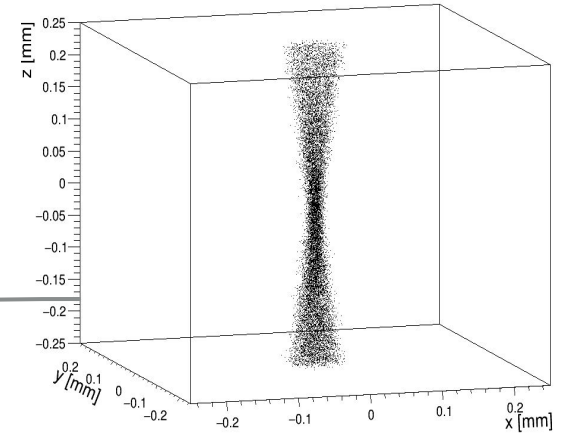
One cannot usually know
these a priori

Example simulation pipeline

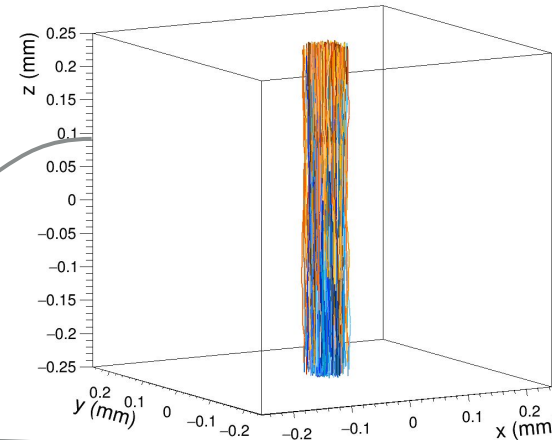
ElectricFieldReader & WeightingPotentialReader
define e.field and w.potential distributions



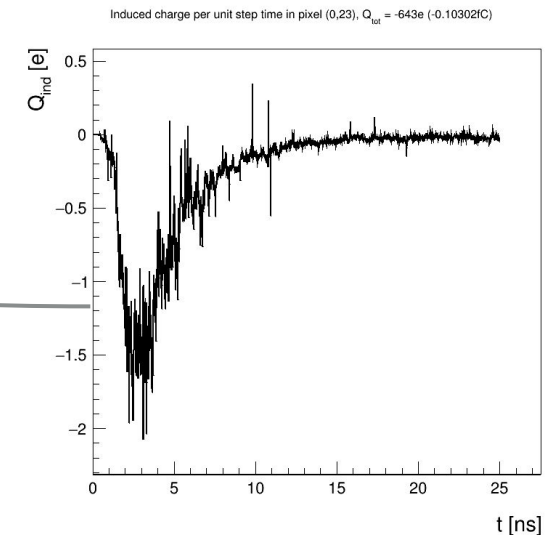
DepositionLaser
generate charge carriers, deposited in the bulk



TransientPropagation
track individual carriers through the bulk and calculate induced currents (Shockley-Ramo)



PulseTransfer
accumulate induced currents and store data



Pulse post-processing (external)
account for the amplifier effects

TCT experiments: Data/MC comparisons

Laser-TCT experiments

A flexible testbench for sensor R&D

Pulsed lasers are a common tool for charge injection:

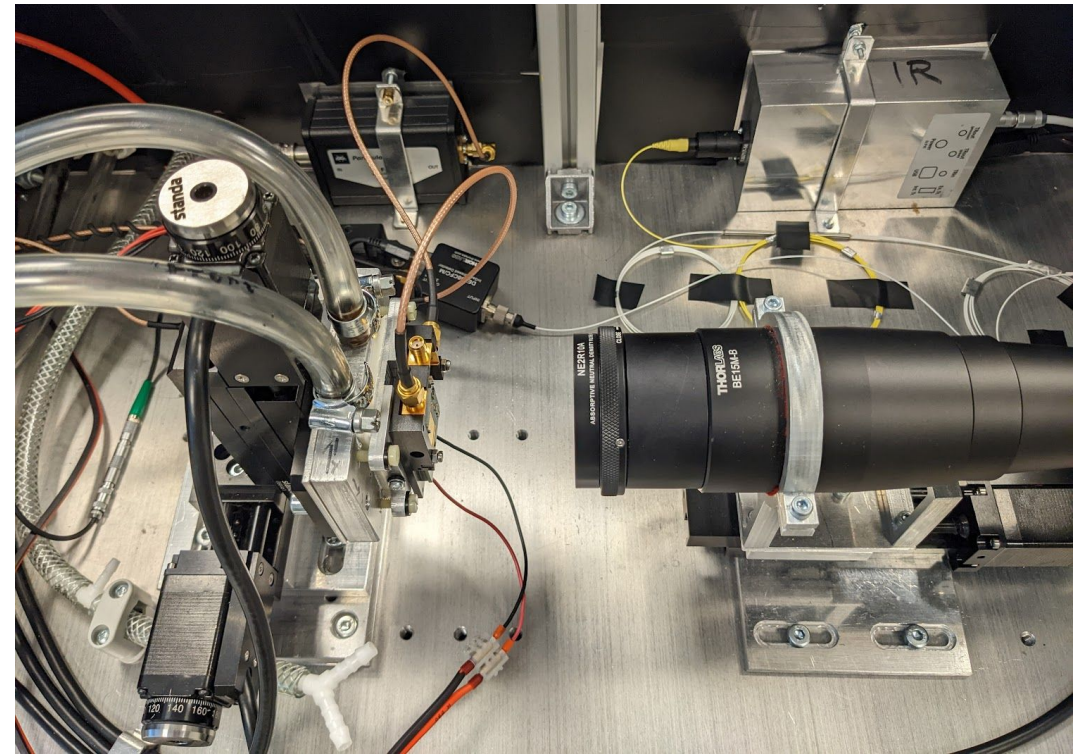
- micrometer aim precision
- high repeatability
- tunable intensity

Red
pen.depth $O(\mu\text{m})$
= *heavy particle absorption*

Near infrared
pen.depth $O(\text{mm})$
= *m.i.p passage*

Red (672 nm) and IR (1064 nm) lasers:

- beam can be focused to a spot up to **$\sim 10 \mu\text{m}$**
- pulse duration of approx. **50 ps**
→ **\sim negligible w.r.t. signal collection time**,
thus does not significantly affect waveforms



Experimental setup at DESY

A few more components to make a complete setup:

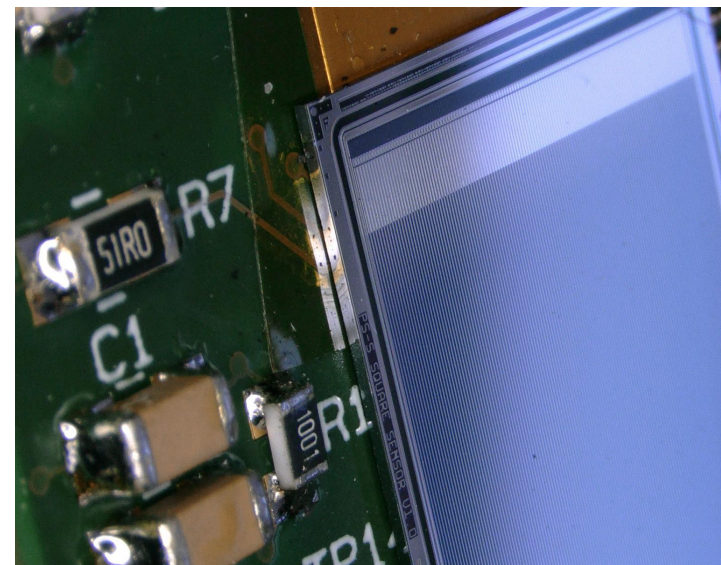
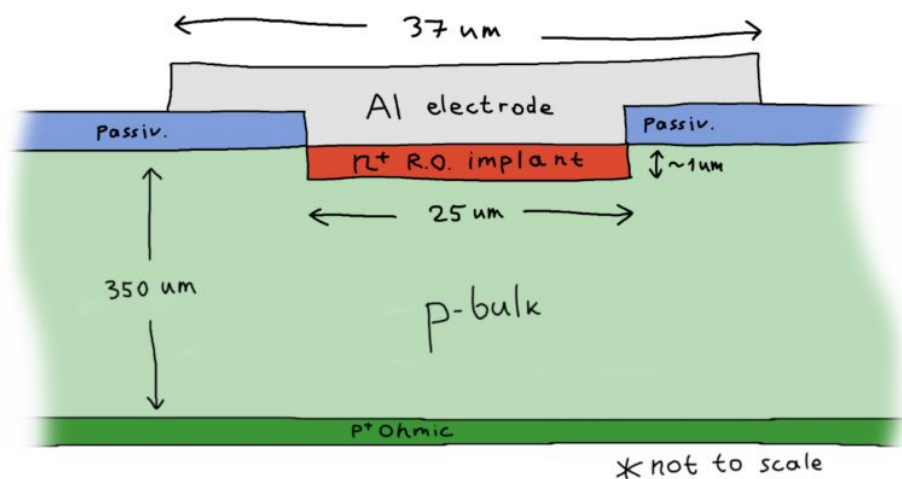
- Focusing optics
- Positioners
- High-bandwidth (2 GHz) amplification and readout
→ **BW not infinite thus has to be accounted for**

The sensor

Strips and strips

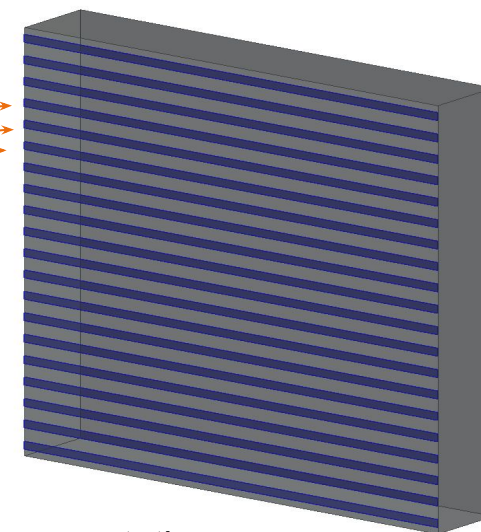
“Baby PS-s”: a strip sensor demonstrator for CMS Phase-2 Outer Tracker

- 350 μm thickness
- 100 μm pitch
- n-in-p (electron-collecting)
- depletion at $\sim 280\text{V}$



The Real Thing on a PCB

Alu electrodes block light!
needs to be accounted for



The Allpix Squared Representation

Sensor model for APSQ + TCAD

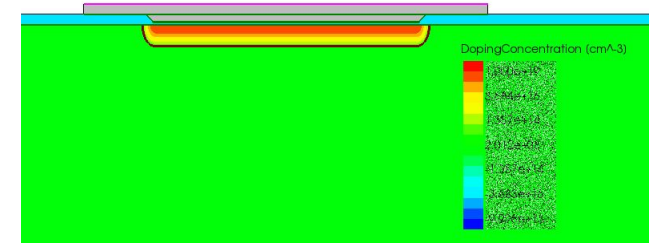
Precise models for precise simulations

For modelling of charge propagation in transition regions (e.g., next to implants), precise field models are **crucial** → especially for **red-TCT**

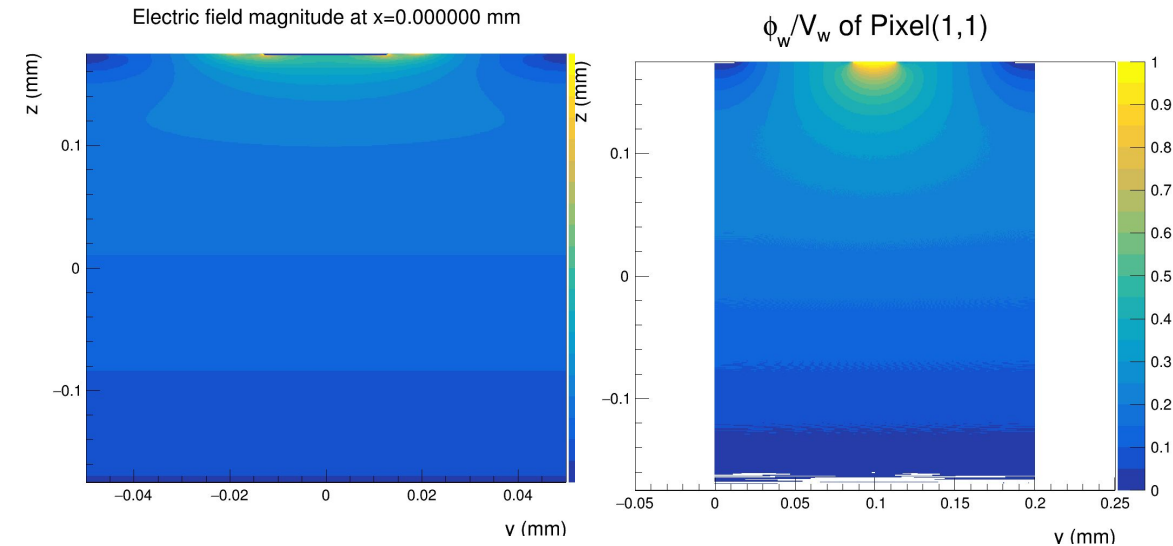
Solution: use TCAD

- 2D field model is sufficient for a *strip sensor*
- Exact bulk doping is not known of course → set it in TCAD such that V_{depl} matches the real sensor
- TCAD model accounts for non-zero depth of readout implants → use 3D implants in Allpix to ensure proper collection

Also: performance benefit in [TransientPropagation]
“mesh” WP model is much faster than “pad”



Doping profile

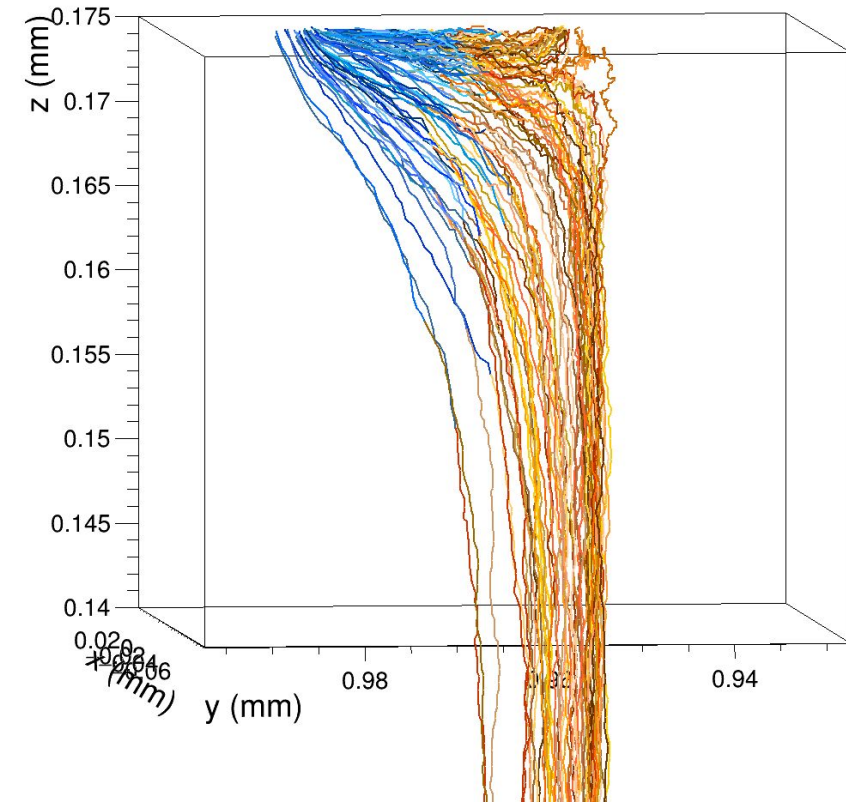
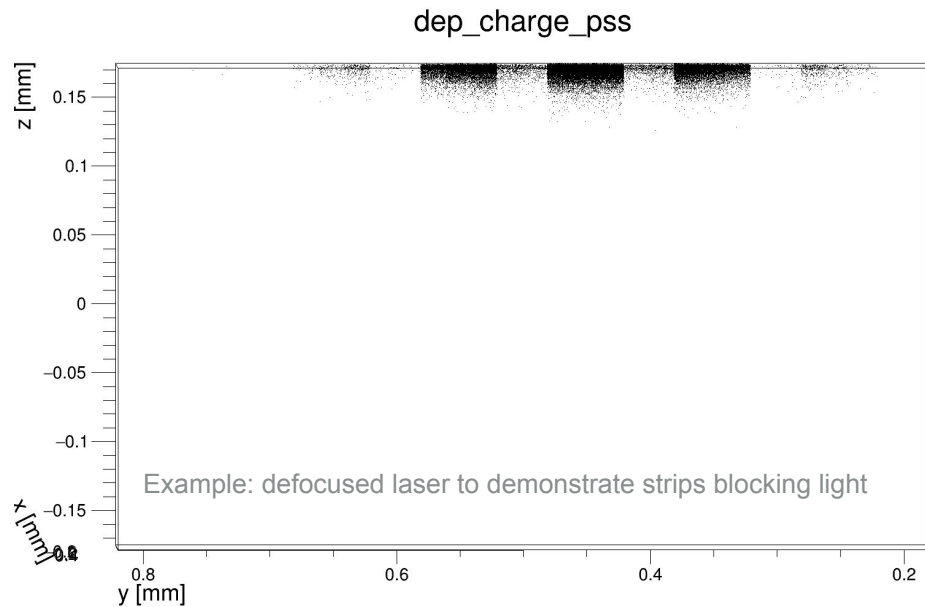


Electric field magnitude

Weighting potential

Red laser injection

Signal formation



All the deposition is happening in a thin layer close to collection implant:

- Prompt pulse from electrons
- The hole cloud drifts through the whole bulk, *profiling the electric field*

Red laser injection

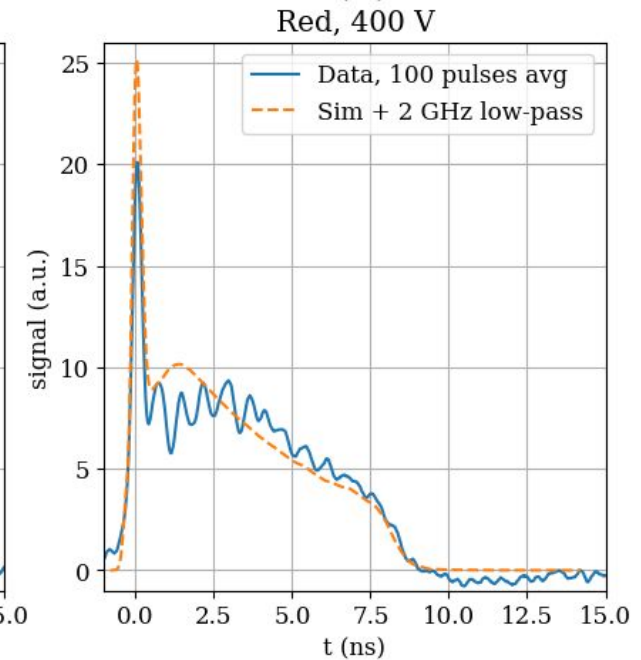
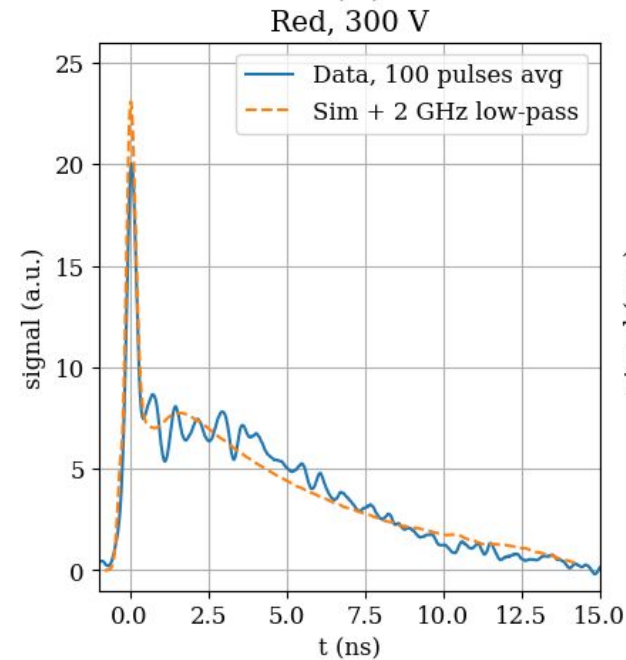
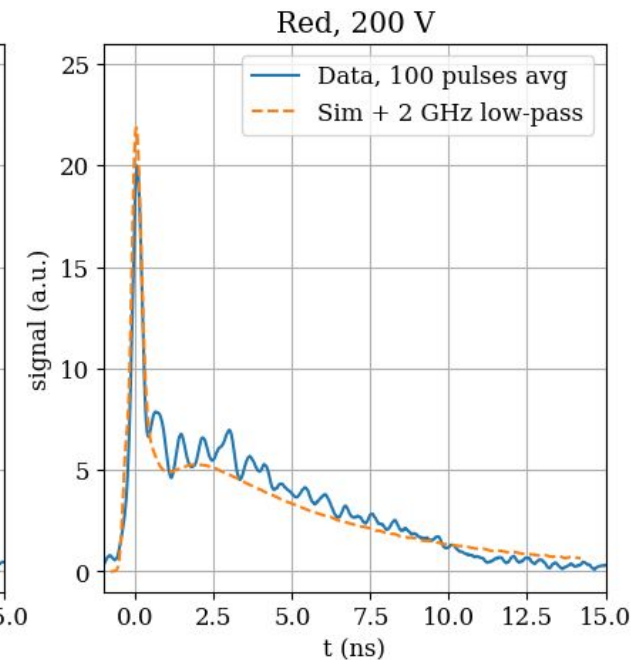
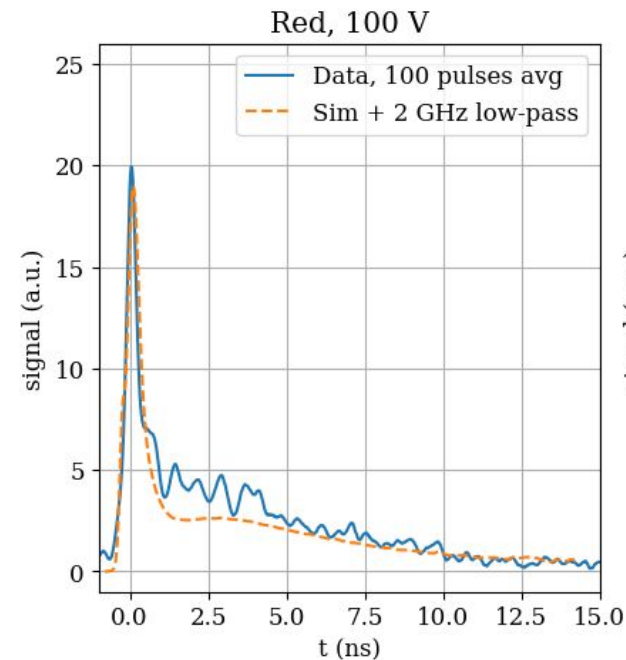
Data/MC comparison

Comparison:

- Electron peak: integral should be unaffected by the bias V
 - Data: the amp is insensitive to small width changes
 - Sim: the peak becomes sharper with V increase
- Hole component: roughly reflects E-field z-profile
 - Increases with V
 - Sharper cut-off if V_{depl} is exceeded
 - Good data/sim match!

Challenges:

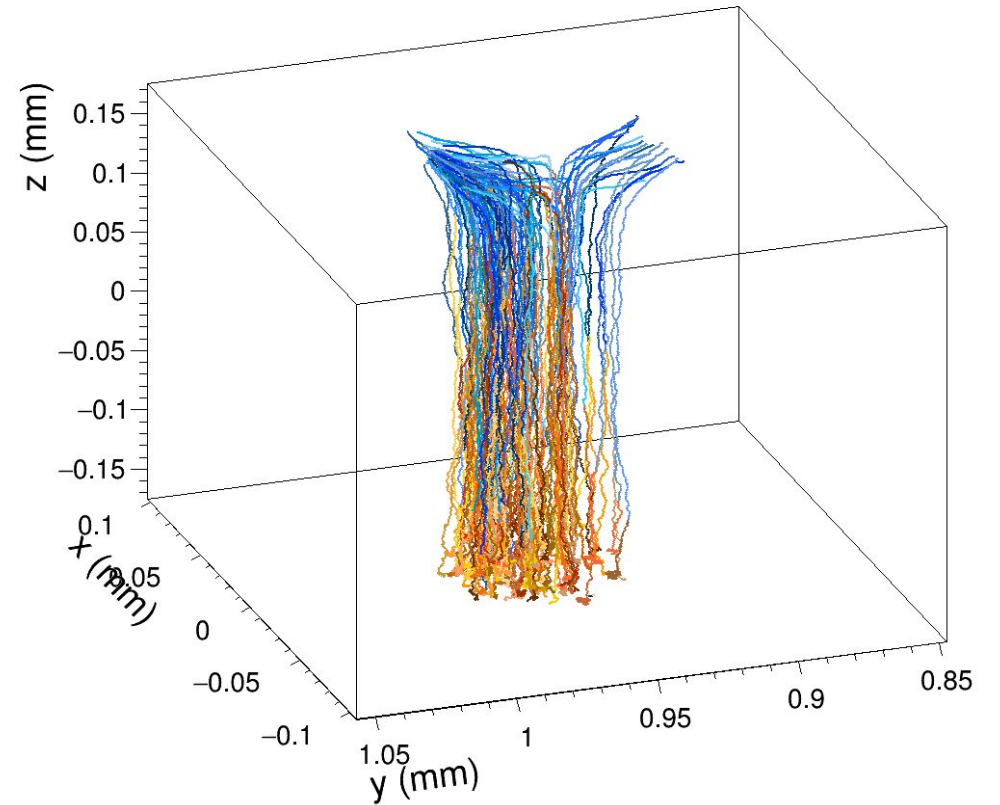
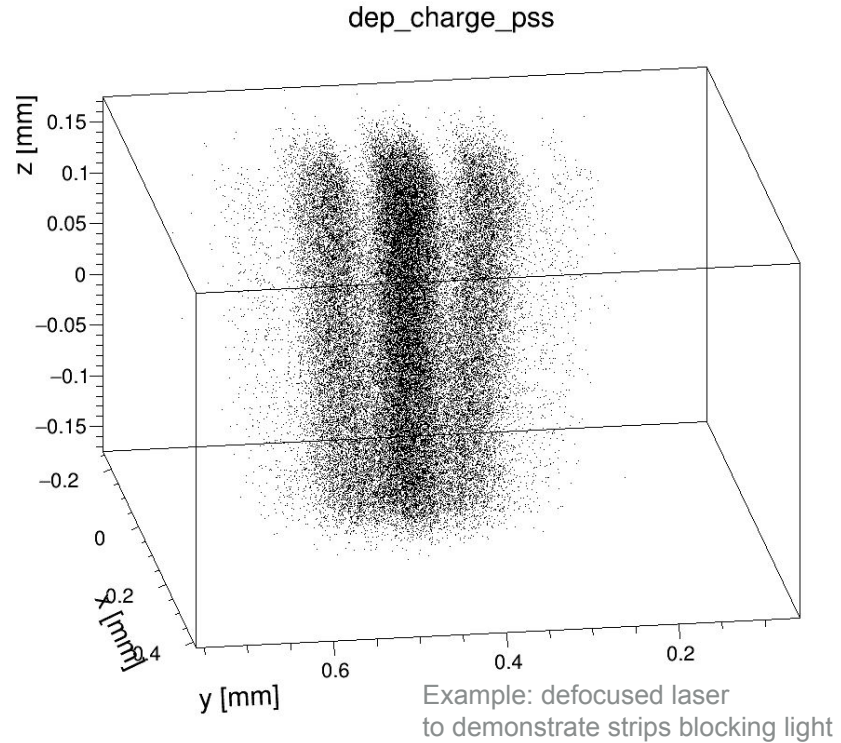
- Signal shape (both data and sim) is highly affected by the exact injection location
- Simulated shape of hole component is highly affected by the mobility model → here: “**arora**”
- Oscillation in the measured signal: interference from the laser → partially dealt with by moving the laser head further from amps



work in progress

Infrared laser injection

Signal formation



Deposition is ~uniform along the bulk

- Decaying component from electrons (*relatively fast*)
- Decaying component from holes (*relatively slow*)

Infrared laser injection

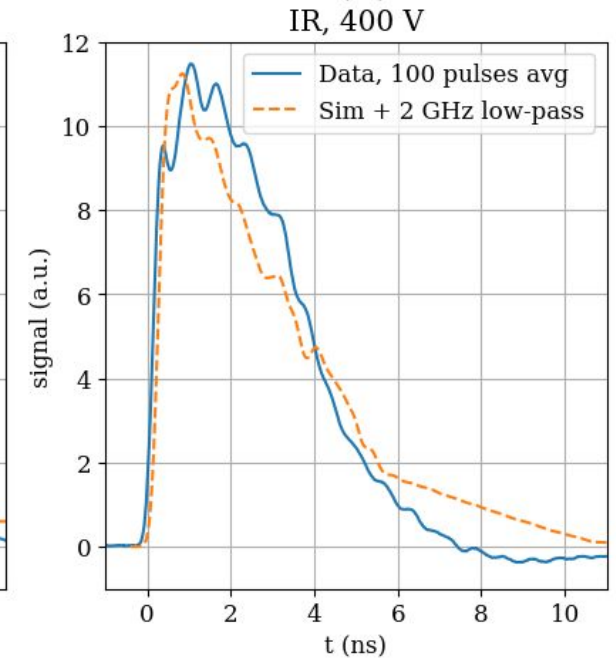
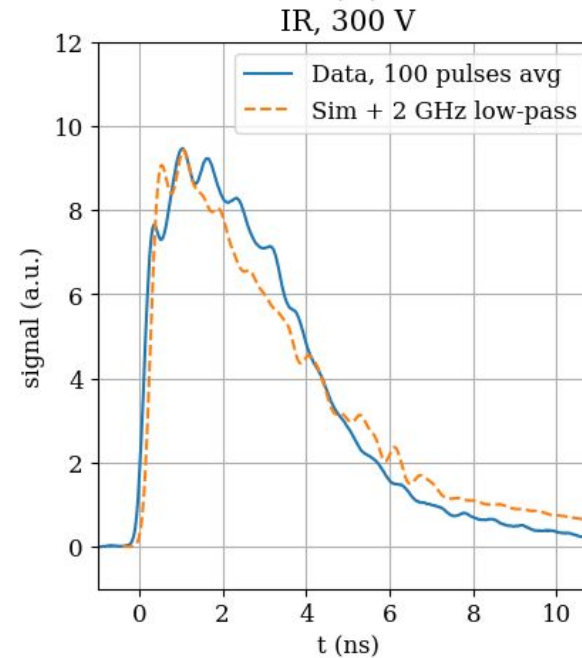
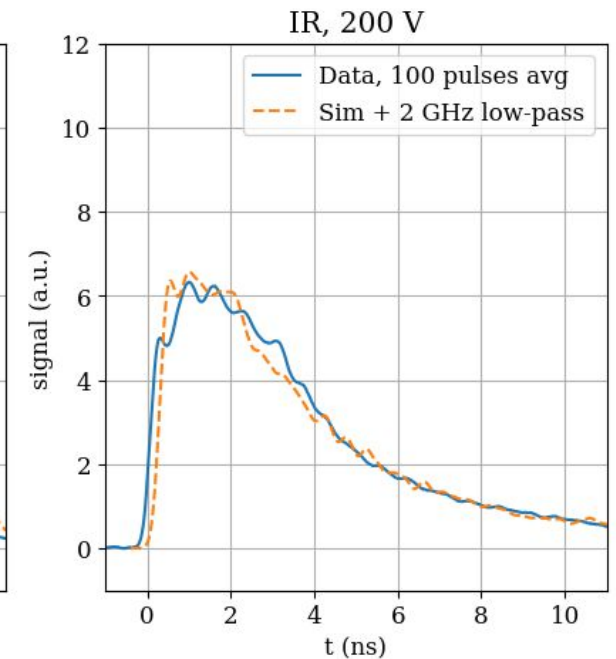
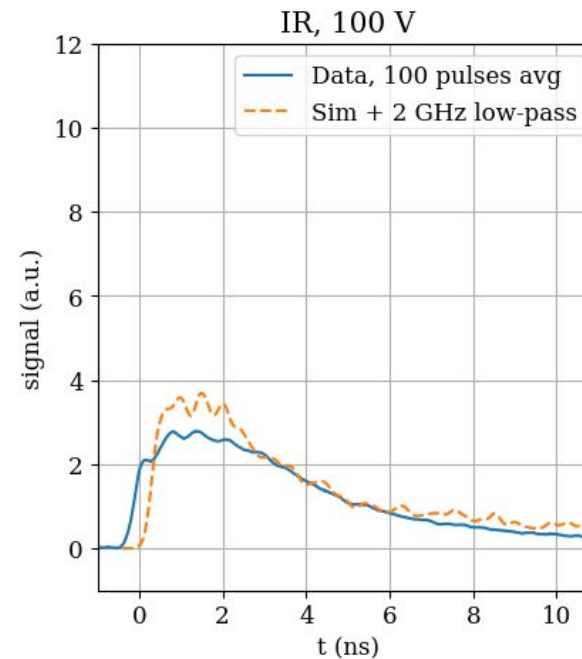
Data/MC comparison

Comparison:

- Total induced charge:
 - Increases with V , as active sensor thickness increases
 - As V_{depl} is reached, the pulse integral is unchanged
- The slowest part at under-depleted sensors: diffusion from the no-field region
 - Overestimated by simulation

Challenges:

- Simulated shape of both components is highly affected by the mobility model → here: “**jacoboni**”
- Proper mobility estimate requires knowledge of doping concentration!
- More accurate estimate of diffusion needed
- Oscillation in the measured signal: interference from the laser → partially dealt with by moving the laser head further from amps



work in progress

Conclusions

- The **deposition generator** for laser-TCT simulations is complete and functional
- With it, Allpix² is capable of reproducing sensor response in different scenarios of **TCT experiments**
 - Certain scenarios show **good match** to experimental data
 - However, **further tuning** of simulation is required for better precision and to cover wider range of use cases

That's it!

Thank you for attention!